

Notice of References Cited

Application/Control No.

10/018,426

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

David M Brunsman

Art Unit

1755

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,767,030	06-1998	Kim et al.	501/136
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	CAPLUS 2003:354765, Kim et al, "Structure and microwave dielectric properties...", 2003
	V	CAPLUS 1999:593074, Kim et al, "Microwave dielectric ceramics..." 1999
	W	CAPLUS 1999:818005, Kim et al. "Low-temperature sintering and..." 1999
	X	CAPLUS 2000:41577, Kim et al., "Low-fired (Zn,Mg)TiO3 microwave dielectrics" 2000

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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	U	CAPLUS 2000:896800, Purvanova et al, "Preparation and some properties of..." 1999
	V	CAPLUS 1998:395995, Kim et al, "Microstructure and microwave dielectric properties..." 1998
	W	CAPLUS 1977:537379, Sheinkman et al, "Phase formation sequence during the reaction..." 1977
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